11th International Conference on HEAVY ION ACCELERATOR TECHNOLOGY

RCNP cyclotron facility

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Outline

- 1. Overview of the RCNP facility
- 2. FLAT-TOP acceleration by the AVF cyclotron
- 3. 18-GHz ECR ion source
- 4. Some results with heavy ion beams
 - γ -decay of high-spin isomers
 - Production of ²¹⁰Fr for electron EDM search
- 5. Summary

Research Center for Nuclear Physics, Osaka University

Cyclotron Laboratory : Nucleon, Meson, Hadron Physics

AVF cyclotron with K=0.14 GeV and Ring cyclotron with K=0.4 GeV Polarized p,d & light heavy ion with Ep=0.01 \sim 0.4 GeV , E/A=0.01 \sim 0.1 GeV



Laser Electron Photon Laboratory : Quark Nuclear Physics 1 ~ 3.5 GeV Polarized Photon Beams by Back Scattering of Laser Photons (2 ~ 6 eV) from 8 GeV electrons at Spring-8



West Harima, pring8, Hyogo Suita, Osaka Tentsuji-tunnel in Ohto, Nara

Chio Cosmo Observatory : Lepton Nuclear Physics L'inderground laboratory with low background (500 m depth, 10 Bq/m³ Rn & 4*10⁻³/m²/s cosmic μ Double b-decay, Dark matter search, etc.



RCNP Cyclotron Facility







Operating statistics



Operating statistics in 2007



RCNP K140 AVF Cyclotron

: 3.3 m

: 1.6 T

: 16 sets

: 3 ~ 5 sets

: 400 tons

: 20.6 cm ~ 34.7 cm

<u>Magnet</u> •Pole diameter •Pole gap •Averaged field •Trim coils •Valley coils •Weight

Acceleration system

Dee : Single 180 degrees type
Resonator : Moving short
Frequency : 6 ~ 18 MHz
Max. acceleration voltage : 80 kV
Extraction system: Electrostatic deflector
FT system (k=5,7,9)

<u>Ion Sources</u> •External ion source

: Atomic beam type polarized ion source, ECR ion source 18 GHz SCECR ion source





RCNP K=400 Ring Cyclotron

Magnet

| Sector magnets | : 6 |
|--------------------------------------|------|
| •Pole gap | : 6 |
| •Maximum magnetic field | : 1 |
| •Trim coils | : 36 |
| Injection radius | : 2 |
| •Extraction radius | : 4 |
| •Weight | : 22 |
| | |

| Acceleration system |
|----------------------------|
| •Single gap type |
| •Frequency |
| •Max. acceleration voltage |
| •RF power |

: 6 sets : 6 cm : 1.75 T : 36 sets : 2 m : 4 m

- : 2200 tons
- : 3 sets : 30 ~ 52 MHz : 500 kV

: 250 kW/cavity

Flat-top cavity •Single gap type •Frequency

: 1 set : 90 ~ 156 MHz



World first FT system operating at variable frequencies





Energy (MeV)

RCNP AVF

Voltage Waveform of Fundamental and FT acceleration Using 3rd, 5th, 7th and 9th Harmonic Frequencies



FT system for the AVF cyclotron



Modification of the Dee Electrode



Dee Voltage Pickup

Dee-voltage pickup electrode



facing the Dee electorode, placed near the acceleration gap, used for regulation of RF system.

Example of the pickup voltage waveform

87MeV 4He2+ (400MeV @Ring) $f_1 = 10.144$ MHz $f_5 = 50.720$ MHz



18 GHz Superconducting ECR Ion Source

Highly charged heavy ions

A variety of heavy ions at high intensity



Plasma Chamber

Φ**80x380L**、1800cm³

Plasma Chamber: Al liner of 1 mm in thickness inside of plasma chamber







~1T on the chamber wall



Ion Currents (eµA)

 $* \rightarrow$ Optimized for these ions

| | 2+ | 3+ | 4+ | 5+ | 6+ | 7+ | RF |
|--|--------------|------------|------------|--------------|--------------|-----|------|
| ¹¹ B (⁴He) ※1 | 1.3 | 4.1 | 9.3 | * 8.2 | | | 400W |
| ¹² C (CH4) (⁴ He) | | | 410 | * 115 | | | 500W |
| ¹⁵ N (⁴ He) | | 167 | 477 | * 725 | 117 | | 500W |
| ¹⁶ O (⁴ He) | 10 | 178 | | * 779 | 517 | 27 | 500W |
| ¹⁸ O (⁴ He) | | 88 | 235 | 475 | * 673 | 39 | 500W |
| | 11+ | 12+ | 13+ | 14+ | | | |
| ⁴⁰ Ar (¹⁶ O) | * 188 | 70 | 17 | 3 | | | 500W |
| | 20+ | 21+ | 22+ | 23+ | 24+ | 25+ | |
| ⁸⁶ Kr (¹⁶ O) | 32 | 26 | 21 | *13 | 8.1 | 4.5 | 600W |
| | 28+ | 29+ | 30+ | 31+ | 32+ | 33+ | |
| ¹³⁶ Xe (¹⁶ O) | 11.3 | 10.6 | 8.8 | 6.2 | * 4.2 | 2.3 | 770W |
| | comparabl | e ion bean | ns from NI | EOMAFIOS | 6 | | |
| | | | 4+ | 5+ | 6+ | 7+ | |
| ¹⁴ N | | | 110 | 65 | 6 | | |
| ¹⁶ O | | | 80 | 30 | 10 | 0.2 | |

 $\times 1$ MIVOC Method with o-carborane (C₂B₁₀H₁₂)

- Bean intensity is increased by one order of magnitude compared to the existing NEOMAFIOS.
- Highly charged ions become available for heavier elements.

Bypass & diagnostic beam line

Object point

Emittance monitor: Profile measurement

安

Emittance monitor: Slit

Vertical Imະອາບອ່ອງint

Bypass & diagnostic beam line

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EN (Exotic Nucleus) beam line



RCNP Ge array

14 Ge det.total efficiency1.9 % at 1.3 MeV

14 Ge + 6 BGOACS total efficiency 1.0 % at 1.3 MeV





Ge det. : Dep. of Phys. & RCNP Osaka Univ., Dep. of Phys. Tohoku Univ., SUNY

search for high-spin shape isomers in *N*=83 isotones ¹⁷N **RI beam** fusion reaction



Gamma-rays by secondary fusion reaction were observed.



Oven target and surface ionizer to produce ²¹⁰Fr for e-EDM measurement





 ϕ 50 μ m Au

Thermocouple



Surface ionizer

2

Spectrum of α -particles (log scale)



Summary

- The RCNP cyclotron facility provides a variety of ion beams in a wide energy region.
- Developments are in progress to increase research opportunities.
 - FT system
 - SCECR ion source
 - Optimization of the central region to improve the transmission through the AVF cyclotron.

Thank you for your attention